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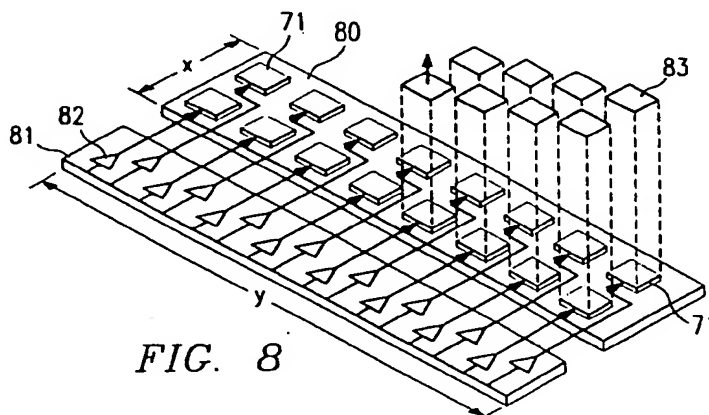
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W-8000 München 60(DE)(54) **System and method for solid state illumination for DMD devices.**

(57) There is disclosed an optic system for illuminating a DMD array in a xerographic printing process consisting of an array of LED emitters (80) constructed to efficiently replace the conventional tungsten source used in prior art. The array can be geometrically configured or electrically operated by

strobing or varying the brightness of individual pixels (71) to compensate for other system optical deficiencies and results in improved printing process. By exposure strobing the LED source correction for fuzzy line edges can be achieved.

**FIG. 8****EP 0 493 800 A2**

TECHNICAL FIELD OF THE INVENTION

This invention relates to a DMD devices and more particularly to illumination systems and methods of operation for such devices.

BACKGROUND OF THE INVENTION

The use of semiconductor light modulators is gaining in popularity as a replacement for the laser polygon scanner in xerographic printing processes. A technology of preference, due to its monolithic, semiconductor fabrication process, is the deformable mirror device (DMD). Copending patent application entitled "Spatial Light Modulator Printer and Method of Operation", published under the number EP 0 433 985, assigned to the common assignee with this patent application, which patent application is hereby incorporated by reference herein, discusses one embodiment of a DMD device using a tungsten light focused via optics on a DMD array. While the invention in that application functions very well, several areas of improvement have become apparent.

These improvements center around the reduction in power consumed, reduction in physical size and uniformity of light modulation across the DMD array. Tungsten sources, like all incandescent filaments, emit light, more or less isotropically, which must be gathered and focused if the light energy is to be efficiently utilized. In addition, a major by-product of incandescent light is the production of heat which in turn demands an ability of dissipating the heat. This, in turn, requires bulky structures, or plenums, to move the heat away from the source, as well as fans with inherent noise/reliability issues.

Because incandescent light is lambertian in its emission character, the rays must be collected from all sides of the filament and focused, thereby requiring fast optics which again argues for large size and cost, to avoid wasted power due to collection inefficiencies.

Accordingly, one problem in prior art DMD structures is the excessive power required to support the light source coupled with large size, both for the optics and for heat disposition. The aforementioned patent application shows the DMD array positioned in the light energy stream between the light source and the imaging lens aperture. In order to achieve maximum energy transfer, it is necessary to fill the imager aperture with the modulated light image from the DMD array. The imager lens is designed, for cost and other reasons, to be round and thus a square filament image aspect ratio magnified to overfill the imager, must be presented to the lens to insure that the lens is filled. This arrangement, while performing properly, suffers from the problem that not all of the power modu-

lated by the DMD can be passed by the imaging lens, and not all of the light collected by the condenser lenses can be concentrated on the DMD active area.

The latter problem exists for printing systems in that a DMD array is necessarily elongated or linear in aspect, and thus the light pattern reaching the array must be wider than it is high by a significant proportion, compared to either the filament aspect ratio or the aperture of the imager, both of which can be thought of as approximated by a square. Because the source must simultaneously come to focus on the imaging lens circular aperture and at the same time uniformly illuminate the full length of the DMD modulator which is maintained between the aperture of the collimator lens and the focusing lens and since the DMD device is substantially wider than it is high, in order to fully illuminate the array the resulting aspect of the light necessitates considerable width of illumination above and below the active area of the DMD device that is subsequently "wasted".

Another problem is that the focused image from the DMD is continuously projected onto a moving drum. Thus, during the exposure period of a dot-line, for any pixel image location the drum will rotate a given distance and broaden or blur that pixel image. A plot of the light energy on the drum for that pixel location will reveal that the maximum light energy transferred to that pixel will reach a peak level only at the centroid of the pixel and will build up to that point and fall off from that point in the shape of a pyramid. This pyramidal spreading of the pixel energy is not optimum for minimum feature formation and thus reduces the sharpness of the xerographic image in the process direction.

A further problem with existing DMD structures and systems is the fall-off of the light energy on the outer periphery of the DMD array, particularly with elongated arrays, due to the difficulty in collecting and directing light energy from lambertian filament sources.

A still further problem with such existing systems is that optic intensity is not constant or uniform over the whole filament array and there is not a practical method for adjusting the optic characteristics of the light source after manufacture.

Another problem is that the generally available tungsten light sources have filament aspect ratios that are not optimum for DMD light modulator systems. Another problem is the relatively limited lifetime of the tungsten sources.

A final deficiency of the tungsten source is that of the thermal inertia, or lag time of the filament, making it impossible to vary the light output of the source within a printing line time, as is desirable to compensate for specific printing deficiencies.

SUMMARY OF THE INVENTION

A solid state optical source, such as a light emitting diode (LED) array, has been substituted for the tungsten light source in conventional DMD devices. The LED array can, in one embodiment, be fashioned as a single unit with individual lenses and LED chips arranged to make up various array structure configurations. Alternatively the structure can be a substrate of flexible material on which has been fashioned an array of LED chips and lenses. Each lens is associated with an LED emitter or a group of LED emitters so that the light from said emitters is efficiently directed and focused onto a particular region of an opposing DMD array or an intervening optical element that further shapes the ray to bundle prior to the DMD.

Using this structure and method results in lower total power at the light source and its associated power supply, smaller optics due to the efficient light collection of the integrated lens arrays, and thereby eliminates the need for cooling fans. An added benefit is an ability to adjust the light pattern by the geometry of the array or by flexing the structure so as to compensate for the inherent nonuniform effects of tungsten. This enhancement can be accomplished during the manufacturing process and can also be fine tuned during operation of the systems.

The individual elements of the solid state light source can also be electronically adjusted, both at manufacture and during operation so as to improve the light transfer characteristics of the DMD array.

Accordingly, it is one technical advantage of this invention that a solid state light source, such as an LED array, can be used as a replacement for the incandescent light source in a DMD array.

It is a further technical advantage of this invention that a DMD array is integrated with a compact, flexible solid state light source that can be adapted or configured to allow for optical adjustment to compensate for uneven illumination of the DMD array, as well as to improve illumination characteristics and modulation efficiency of the DMD system.

It is a further technical advantage of this invention that the LED illuminator and DMD light modulator system can together be operated in a manner to improve the print quality of a xerographic printing process.

BRIEF DESCRIPTION OF THE DRAWINGS

A more complete understanding of the present invention may be acquired by referring to the detailed description and claims when considered in connection with the accompanying drawings in which like reference numbers indicate like features

wherein:

FIGURE 1a, b and c show characteristics of the prior art filament source light;

FIGURE 2 shows the prior art source light projected through lenses to form an image;

FIGURE 3 shows a graph of the intensity of prior art light from a tungsten source indicating the relative wave length region of interest for the printing process;

FIGURE 4 is a schematic of the elements of the prior process;

FIGURES 5a, b and c show the problem of illumination uniformity with the prior art and the correction or compensation with the present art;

FIGURE 6 shows a schematic assembly of the LED array and the initial optics that would go with that module;

FIGURES 7a, 7b, and 7c show configurations of LED's on substrates that could be used;

FIGURE 8 shows an LED array substrate with individually addressable elements;

FIGURE 9a shows an ideal exposure of a pixel;

FIGURE 9b shows the actual exposure in the prior art printing process;

FIGURE 9c shows the exposure strobing that can be accomplished with the proposed invention;

FIGURES 10a, 10b and 10c show the light emission patterns of LED devices with and without primary collection optics; and

FIGURE 11 shows a schematic of the present system uniformly illuminating the entrance aperture of a secondary condenser lens element and then forming a region of uniform illumination and a source image beyond the lens.

DETAILED DESCRIPTION OF THE INVENTION

Turning now to FIGURE 1a, there is shown light element 10 with 50 percent of its light going away from the desired direction, and the remainder of the light going off to the right forming angles theta with respect to a line b normal to the plane of element 10. The significance of arrows a, b and c are that this source is a lambertian source for which the light intensity looks the same to an observer along any direction, so if one does not collect light rays along arrows a and c, which lie well away from central arrow b, considerable portions of the available light energy will be lost. That is in addition to the loss out of the back side of the filament. The filament 10 is indicated as having dimensions x by y which typically are not the desired format for the light source for a DMD system.

FIGURE 1b shows the effect of a light source 10' when magnified to fill an imager aperture 12. By failing to fill it completely in the vertical direc-

tion and overfilling it in the horizontal direction it generally results in system inefficiencies as shown by image 10'.

FIGURE 1c shows filament 11 radiating into a solid angle and illuminating area 11', representing a first lens surface, which is a relatively small portion of the total forward area that is of consideration in the collection. This illustrates that any collection optics that do not virtually surround the front side of the filament are less than 100 percent efficient in collecting the light. To do so, the lens must be either large, or very close to the filament, and less than optimum trade-offs are forced on the designer. This is a characteristic problem of the incandescent filaments which are lambertian radiators.

FIGURE 2 shows the prior art system source 20 radiating to collection lens 21 separated from the filament by some distance r . The solid angle that collection lens 21 therefore represents referring back to FIGURE 1c is determined by its diameter and by that distance r . It simply cannot fill very much of the forward angle into which the filament in source 20 is radiating. That light is collected is subsequently redirected onto condenser lens 22 which is a slabbed section of an asphere and does not collect the entire bundle of energy that is redirected by lens 21 resulting in a further reduction in the delivered light converging to area 23, the region of uniformity where the DMD device schematically resides. This energy is all redirected into filament image 20' at imager lens aperture 24.

FIGURE 3 shows a further deficiency of the prior art, namely, that the spectral intensity of the tungsten source at a nominal temperature of 3,000 K is peaked around 1 micron and the great bulk of the energy radiated lies in the 1-10 micron range, that is, as radiated as heat, and very little of it is in the useful visible range indicated by the band between the lines and which can be utilized in a printing system.

FIGURE 4 details the radiometry of the prior art as previously discussed in FIGURE 2. It shows that any source 40 with radiant output H falling onto collection lens assembly 41 and 42, thereby illuminating DMD plane 43, and subsequently reimaging onto imager lens set 44, 45 and 46 is subject to a certain efficiency at the image plane 47 solely determined by the brightness of the source H , the transmittance of the entire optical system indicated by T , and shown as spread across the entirety of the optical components, and the solid angle, that is, the speed of the imager lens assembly shown schematically by the dotted lines at the output portion of the imager lens assembly. The final DMD image at 47, therefore, has irradiance R , which is determined by the light collection efficiency, the system transmittance and the speed of the imager lens. The only way to improve the

irradiance at the image of the DMD is to either make the source brighter, the imager lens faster, or the system transmittance higher. The system transmittance is typically improved by optical coatings. That is a standard practice in the industry. The speed of the imager lens and its corresponding aperture can only be increased to a practical limit due to the DMD deflection angle, and because higher speed lenses are larger, more costly, begin to affect the DMD exposure module packaging, and generally reach some practical limit at about a speed of F4.5 due to combined factors. The only remaining variable is to increase the system brightness H at the source, or to concentrate the source output power in the spectral region of interest to the printing process.

FIGURE 5a showing radiometry in the prior art details an object plane with a small object simulating DMD 52, an imager 51 and an image of the DMD 50 shown magnified.

FIGURE 5b shows the presumed illumination of object 52, where in the uniform perfect case, from the $-y$ to $+y$ position on the object, it represents a normalized illumination of 1.0 across the entire surface and correspondingly when that image is related to the image plane 50, FIGURE 5c shows again in case A, that the reimaged radiation from the uniform DMD illumination has actually sagged at the sides of image as shown at $-y'$ and $+y'$ and is less than uniform. In the case of the proposed LED illumination system, it is possible to increase the brightness at the extremes of object 52, as shown by the dotted line compensating case B in FIGURE 5b, so that more light is delivered at the edges of the device than at the center. As a result, when the imager has reformed image 50 with the same tendency to roll-off at the ends, we have case B in FIGURE 5c, which is schematically represented by a dotted line showing fairly constant uniformity of illumination across the entire image from $-y'$ to $+y'$.

FIGURE 6 shows the proposed LED illuminator assembly 60 consisting of a primary substrate 61 containing metal conductor lines 63 and multiple LED chips shown 62 arranged in a suitable array positioned with respect to a primary aspheric multilens array 64 containing lens elements 65 which reside above and capture the radiation from each of the LED chips 62. This is a separate lens array which is close to but does not actually contact the LED devices. As a result, each element subtends a large solid angle and is therefore able to receive most of the LED light emission. It is possible to form an immersion lens system where the plastic lens is actually molded over the chips and contains them and seals them from contamination and environmental problems and have the lens element 65 still formed above each emitter element 62. Finally,

a secondary anamorphic lens 66 may be positioned above this, and serve to condense the light more efficiently in a preferred direction. The compact assembly thus formed is basically the replacement for the incandescent source in the prior art. A graded index lens array (not shown) could also be utilized to collect and direct the LED illumination.

FIGURE 7a shows another possible substrate configuration 70, a circle of diameter R_0 which can be precisely the diameter of the imager aperture or smaller, and therefore, can be magnified to precisely fill the circular imager aperture. It is populated with LED chips 71 to achieve the desired radiance levels necessary for the printing process. Another alternative in FIGURE 7b shows substrate 72 which is rectangular in nature. It is populated again with LED chips 71. This would be magnified anamorphically to fill an imager aperture shown as 73 in FIGURE 7c. The dotted line 72' represents the anamorphically magnified substrate from FIGURE 7b shown as just filling the imager lens assembly. The benefit of this type of illumination is that each emitter on the substrate shown in FIGURES 7a and 7b is equally bright or comparably bright, unlike the case of the filament source shown in the prior art FIGURE 1a and 1b, which has a very non-uniform characteristic.

Typically the filament center is hotter and thus brighter, and the edges, particularly where the leads come into the filament, are cool and emit far less energy, so when the imager lens is filled, as shown in FIGURE 1b, with this filament, parts of it are much less efficient in the printing process than is the center so advantage is taken of the full solid angle of the imager lens. Referring back to FIGURE 4, the solid angle of the imager lens is one of the key variables in delivering energy to the photoreceptor surface. If one does not effectively fill that imager lens aperture one does not effectively transmit energy to the photoreceptor. The example configurations shown in FIGURES 7a and 7b allow one to simulate a radiating source, or a physical object that behaves like a filament in the prior art, but which is equally bright at all points, and can be built to the exact aspect ratio that best serves overall system performance. In addition, if the individual LED chips are not equally bright, or if one fails, the system operation is not too compromised. Since each DMD pixel images the entire source to the imager, details of the LED source uniformity are not an extremely critical factor, only the average brightness is of primary significance.

FIGURE 8 shows an additional embodiment of an LED array on substrate 80 looking very similar to FIGURE 7b with the exception that the individual LED chips 71 can now be driven independently through drivers 82 on driver chip 81. Substrate 80 is possibly separate from driver chip 81, but driver

chip 81 could be an integral part of substrate 80. The point here is that under computer control the programmable driver chip can enhance or reduce the light output of the individual elements. The vertical arrow of FIGURE 8 indicates the direction of increasing intensity, indicated by the schematic histograms 83, revealing that the center two elements are emitting at a lower light level than the nearest neighbors which are emitting at a lower level than the most outboard elements of substrate 80. For clarity, the LED elements 71 to the left have the histogram omitted. This relates back to FIGURES 5b and 5c where it is proposed to modify the brightness of the illumination from the source to guarantee that the image plane radiation levels are uniform and constant. So by being able to control the brightness profile of the array of LED chips, correction can be made for other deficiencies in the optical system and to achieve a uniformly bright DMD image.

FIGURE 9a shows an additional advantage of being able to illuminate the DMD with an LED array source. Because the LED arrays can be turned on and off in extremely short periods of time, that is, tenths of microseconds, an option that was not available for a typical incandescent source, we are able to approach the ideal exposure in the printing process. FIGURE 9a shows an ideal exposure, indicated as intensity in the vertical direction, appearing as an instantaneous exposure of light energy from a DMD pixel onto the photoreceptor and representing width l which is the desired pixel line width, or the ideal line width.

FIGURE 9b shows what the actual exposure looks like due to the motion of the photoreceptor with a conventional DMD under continuous illumination. Because the DMD and the light source remain on for a line time, it actually exposes an area prior to the line of interest and after the line of interest and the net result is an exposed image that is a width w , where w is larger than 1, which has characteristic light fuzzy edges as shown in FIGURE 9b. This is an undesirable characteristic of the printing process. A simple way to correct that with the LED source of illumination is shown in FIGURE 9c, where by exposure strobing, that is, turning the LED on for a short period of time at a higher than normal intensity (which is a common operating mode for LED chips) the energy can be concentrated in the region of interest, that is, the line of width l .

For example, by pulsing the DMD at three times the normal intensity, but only for 33 percent of the line time, the effective exposed line width, while it is slightly wider than the desired line width of l , as indicated by width m , is very close to the ideal case shown in FIGURE 9a. There is still a little bit of fuzziness to the edges, but by shor-

tening the period of exposure the gross blurring of the edges that is a characteristic of the prior art shown in FIGURE 9b is eliminated.

FIGURE 10a shows an individual LED chip 101 and the active emitting region 102 referenced to an arrow in the forward direction along O° . FIGURE 10b shows a similar chip 101 with lens array 103 and individual lens element 104 in place, again referenced to the arrow along O° . FIGURE 10c shows the relative luminous intensity of the LED emitter versus the forward angle for each of these two chip configurations.

FIGURE 10c shows the relative illuminous intensity versus the forward angle on the polar diagram. This shows the forward pattern 105 for FIGURE 10b with the lens in place indicating that it is concentrated along the axis 0 degrees at a relative intensity of 1.0.

FIGURE 10c, line 106 is a curve showing the hypothetical emission pattern from LED emitter chip 101, FIGURE 10a without a lens showing that there is much more off axis energy which is not collected and concentrated in the forward direction.

FIGURE 11 shows a preferred embodiment of the invention with integrated LED light array 60 having integral lenses. Ray pattern 111 emanates from LED source 60 and falls on the input aperture of condenser lens 113. The detail shown by circles 112 indicates that the rear aperture of lens 113 is uniformly filled by an overlapping array of multiple bundles of light emanating from individual LED emitters in array 60 according to the prescription of FIGURE 10b.

Once passing through condenser lens 113, the pattern of light proceeds along ray paths 115 to form a magnified image 116 of array 60 which completely fills and slightly overfills the input aperture of imager lens 117. Between condenser lens 113 and imager 117 lies the region 114 of uniform illumination where the DMD chip will reside in the exposure module system.

Implicit in FIGURE 11 is the fact that while the emitter array 60 is a source of nearly monochromatic light, emitted at the characteristic wavelength of whatever LED material is utilized, and falling entirely in the useful band shown in FIGURE 3, the radiation is not coherent as would be the case with a pure laser source of illumination. The multiplicity of emitters are not in phase, hence the disadvantage of coherent sources illuminating very regular periodic structures like the DMD array, which results in significant energy loss into complex diffraction patterns, is not experienced here, thereby preserving the desired optical performance features of the conventional incoherent tungsten source. The imager lens 117 can be less complex for the monochromatic LED array than for the broadband tungsten source as well.

Although this description describes the invention with reference to the above specified embodiments, it is but one example, and the claims, not this description, limit the scope of the invention. Various modifications of the disclosed embodiment, as well as alternative embodiments of the invention, will become apparent to persons skilled in the art upon reference to the above description. Therefore, the appended claims will cover such modifications that fall within the true scope of the invention.

Claims

1. A DMD array comprising:
 - a DMD device operable to modulate light impacting a surface of said device; and
 - a plurality of individual solid state light emitting elements arranged in a unitary structure and focused on said DMD device.
2. The array set forth in claim 1 wherein said unitary structure includes a plurality of individual lenses mated with each said light emitting element.
3. The array set forth in claim 2 wherein at least some of said lenses are anamorphic.
4. The array set forth in claim 1 further comprising:
 - a system for adjusting the relative position of certain ones of said elements with respect to said DMD so as to effect the optical light transfer between said structure and said DMD array.
5. The array set forth in claim 2 wherein said unitary structure is flexible.
6. The array set forth in claim 2 wherein at least some of said elements have different light emitting capability from other such elements.
7. The array set forth in claim 1 wherein light emitted from said elements is uniform as viewed from a plane offset from the plane of said structure along an optical axis.
8. The array set forth in claim 1 further comprising:
 - a system for selectively enabling any of said elements.
9. The array set forth in claim 8 further comprising:
 - a system for varying the on/off time of any of said elements independent from each other.

10. The array set forth in claim 1 further comprising:
a system for strobing said elements.
11. The array set forth in claim 1 wherein said array is used in a xerographic process having a moving receptor and wherein said array includes:
a system for strobing said elements to create sharp pixel images with respect to said moving receptor.
12. The array set forth in claim 11 further comprising:
a system for adjusting said strobe to the movement of said receptor.
13. A xerographic printer comprising:
a source of light;
a DMD device operable to modulate light from said light source impacting a surface of said device and wherein said source of light includes:
a plurality of individual solid state light emitting elements arranged in a unitary structure and focused on said DMD device.
14. The printer set forth in claim 13 wherein said unitary structure includes a plurality of individual lenses mated with each said light emitting element.
15. The printer set forth in claim 14 wherein at least some of said lenses are anamorphic.
16. The printer set forth in claim 13 further comprising:
a mechanism for adjusting the relative position of certain ones of said elements with respect to said DMD so as to effect the optical light transfer between said structure and said DMD array.
17. The printer set forth in claim 14 wherein said unitary structure is flexible.
18. The printer set forth in claim 14 wherein at least some of said elements have different light emitting capability from other such elements.
19. The printer set forth in claim 13 wherein light emitted from said elements is uniform as viewed from a plane offset from the plane of said structure along an optical axis.
20. The printer set forth in claim 13 further comprising:
a system for selectively enabling any of

said elements.

21. The printer set forth in claim 13 further comprising:
a system for varying the on/off time of any of said elements independent from each other.
22. The printer set forth in claim 13 further comprising:
a system for strobing said elements.
23. The printer set forth in claim 13 wherein said xerographic printer includes a rotating receptor and wherein said array includes:
a system for strobing said elements to create sharp pixel images with respect to said rotating receptor.
24. The printer set forth in claim 23 further comprising:
a system for adjusting said strobe to the movement of said receptor.
25. A method of establishing a xerographic printer comprising the steps of:
positioning a DMD device operable to modulate light impacting a surface of said device; and
arranging a plurality of individual solid state light emitting elements in a unitary structure and focused on said DMD device.
26. The method set forth in claim 25 further comprising the step of:
mating a plurality of individual lenses with each said light emitting element.
27. The method set forth in claim 26 wherein at least some of said lenses are anamorphic.
28. The method set forth in claim 25 further comprising the step of:
adjusting the relative position of certain ones of said elements with respect to said DMD so as to effect the optical light transfer between said structure and said DMD array.
29. The method set forth in claim 26 wherein said unitary structure is flexible.
30. The method of operating a DMD array comprising the steps of:
arranging a plurality of individual solid state light emitting elements in a unitary structure; and
focusing light from said elements onto a DMD device operable to modulate said light impacting a surface of said device.

31. The method set forth in claim 30 wherein said unitary structure includes a plurality of individual lenses mated with each said light emitting element. 5
32. The method set forth in claim 31 wherein at least some of said lenses are anamorphic.
33. The method set forth in claim 30 further comprising the step of: 10
adjusting the relative position of certain ones of said elements with respect to said DMD so as to effect the optical light transfer between said structure and said DMD array. 15
34. The method set forth in claim 31 wherein said unitary structure is flexible.
35. The method set forth in claim 31 further including the step of: 20
generating different light levels from various of said elements.
36. The method set forth in claim 35 wherein light emitted from said elements is uniform as viewed from a plane offset from the plane of said structure along an optical axis. 25
37. The method set forth in claim 30 further comprising the step of: 30
selectively enabling any of said elements.
38. The method set forth in claim 30 further comprising the step of: 35
varying the on/off time of any of said elements independent from each other.
39. The method set forth in claim 30 further comprising the step of: 40
strobing said elements.
40. The method set forth in claim 30 wherein said array is used in a xerographic process having a moving receptor and wherein said method includes the step of: 45
strobing said elements to create sharp pixel images with respect to said moving receptor.
41. The method set forth in claim 40 further comprising the step of: 50
adjusting said strobe to the movement of said receptor.

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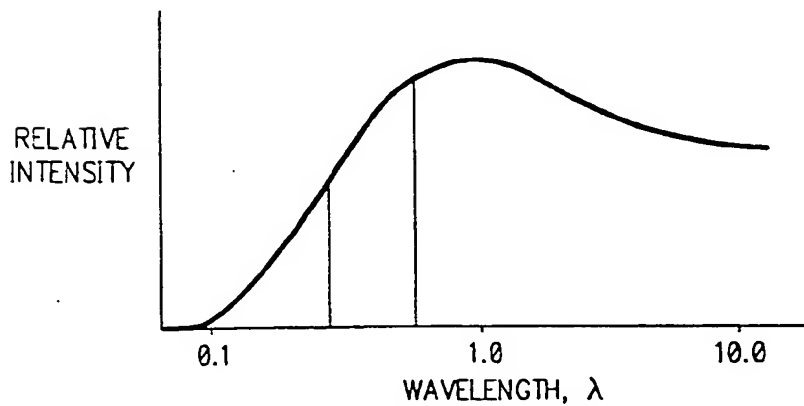
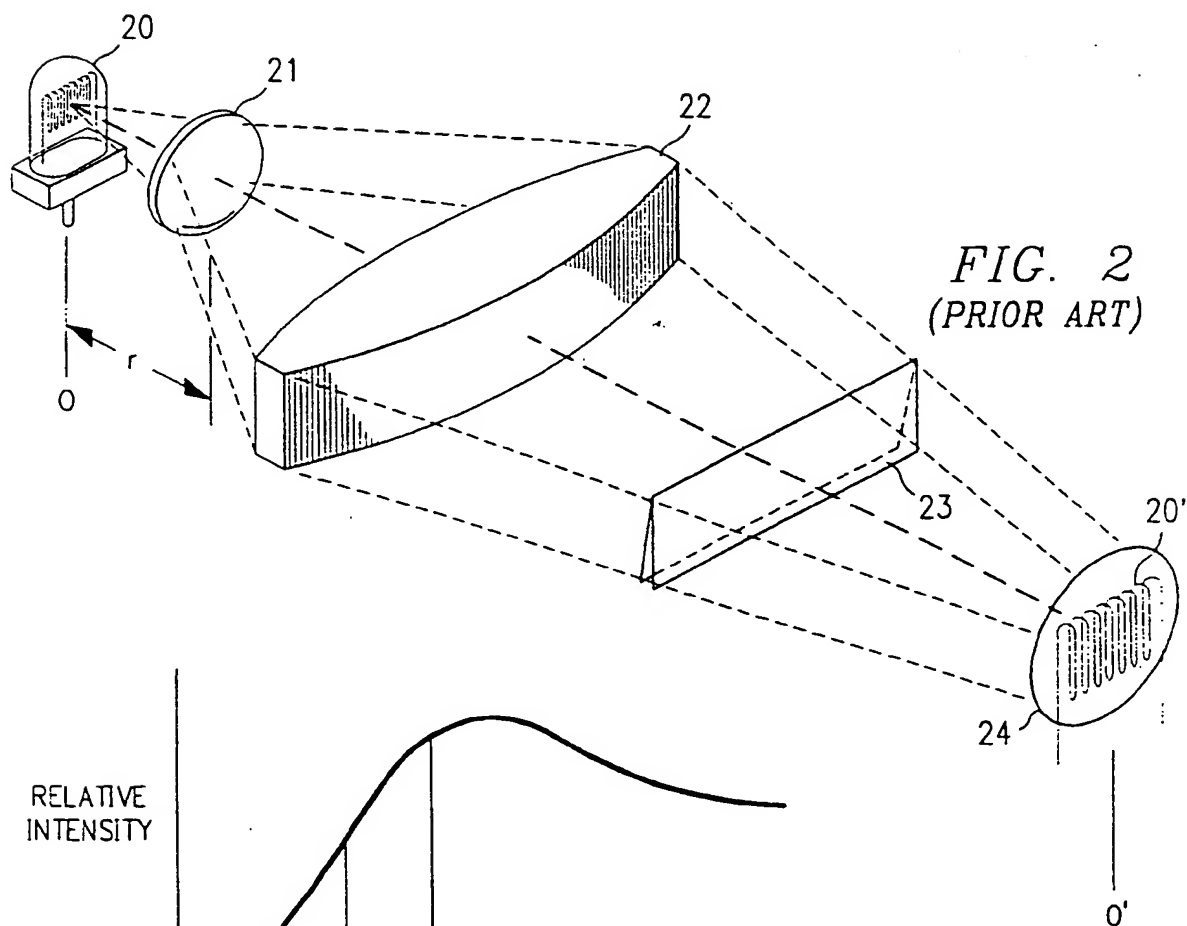
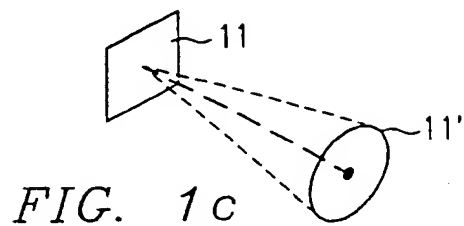
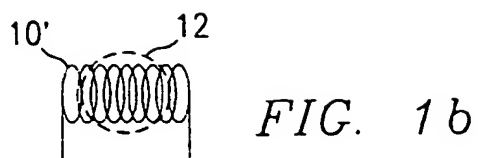
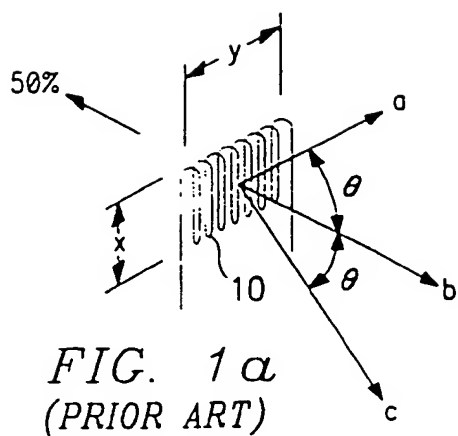
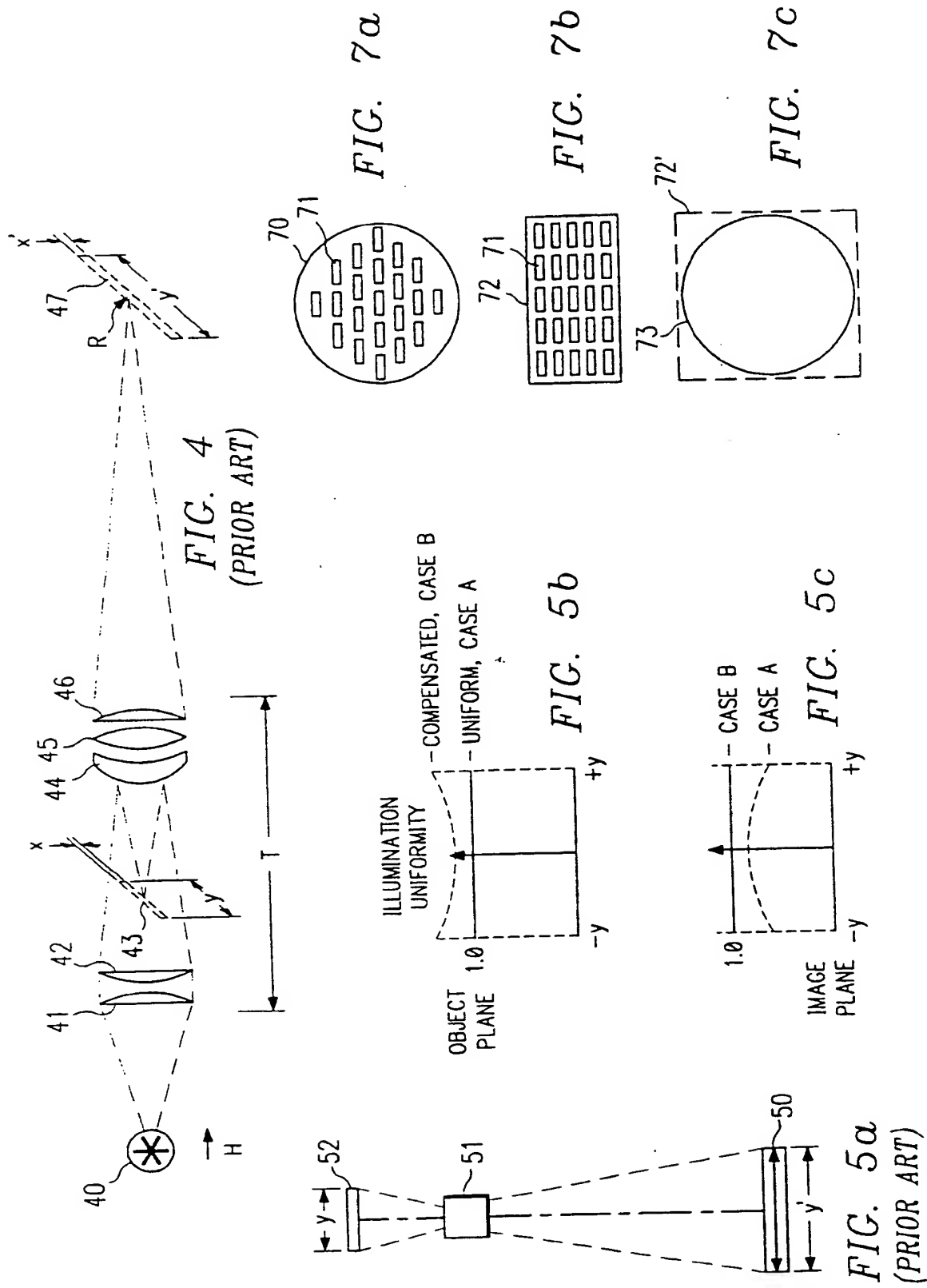
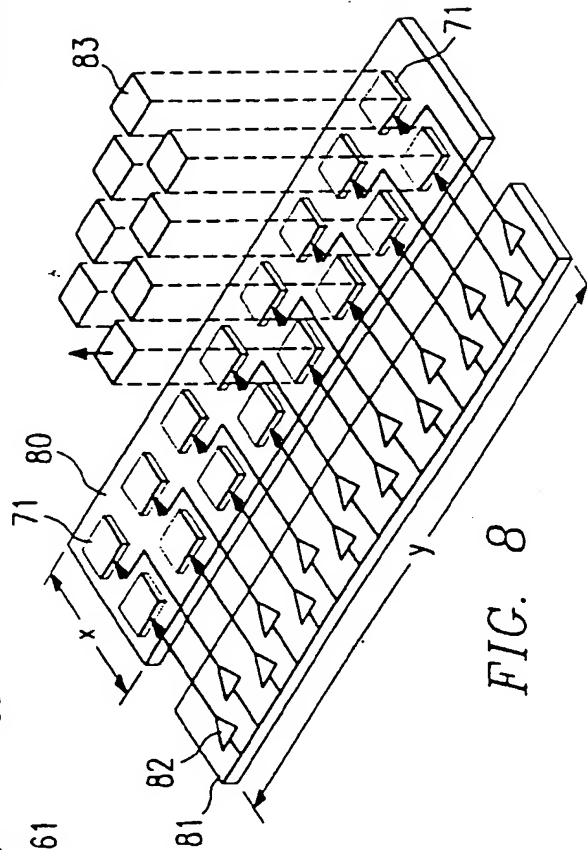
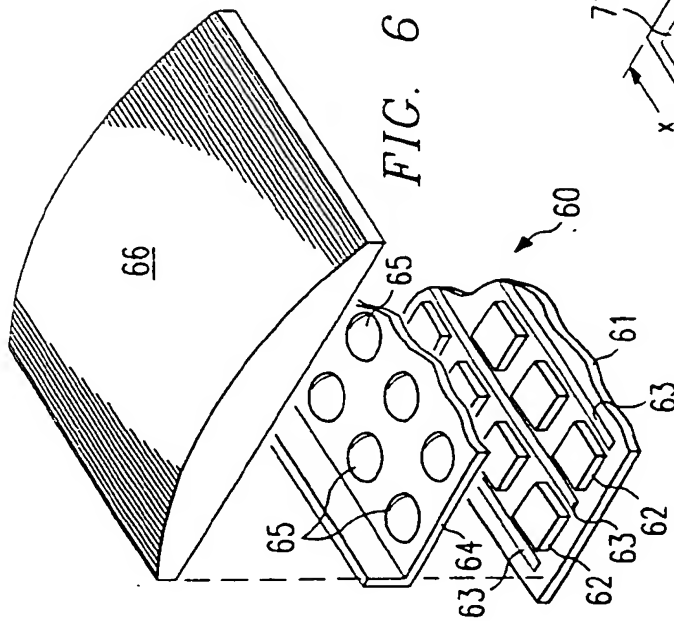
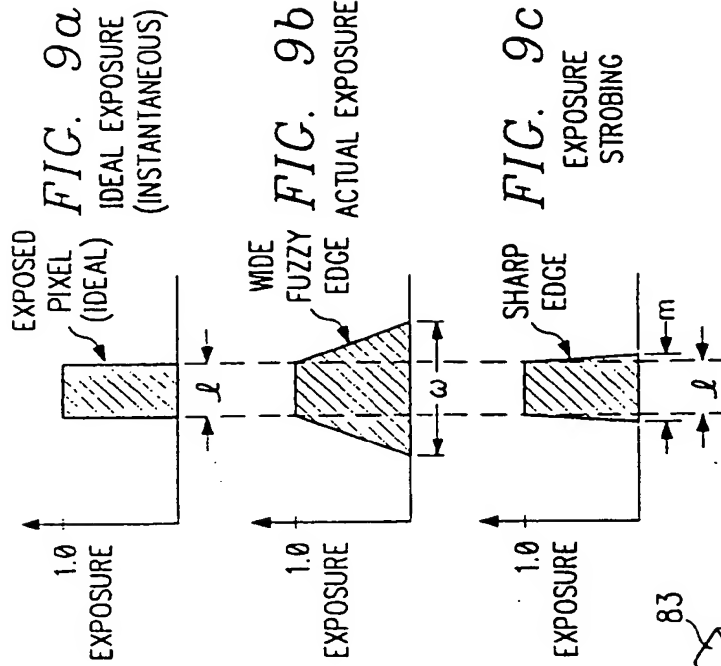
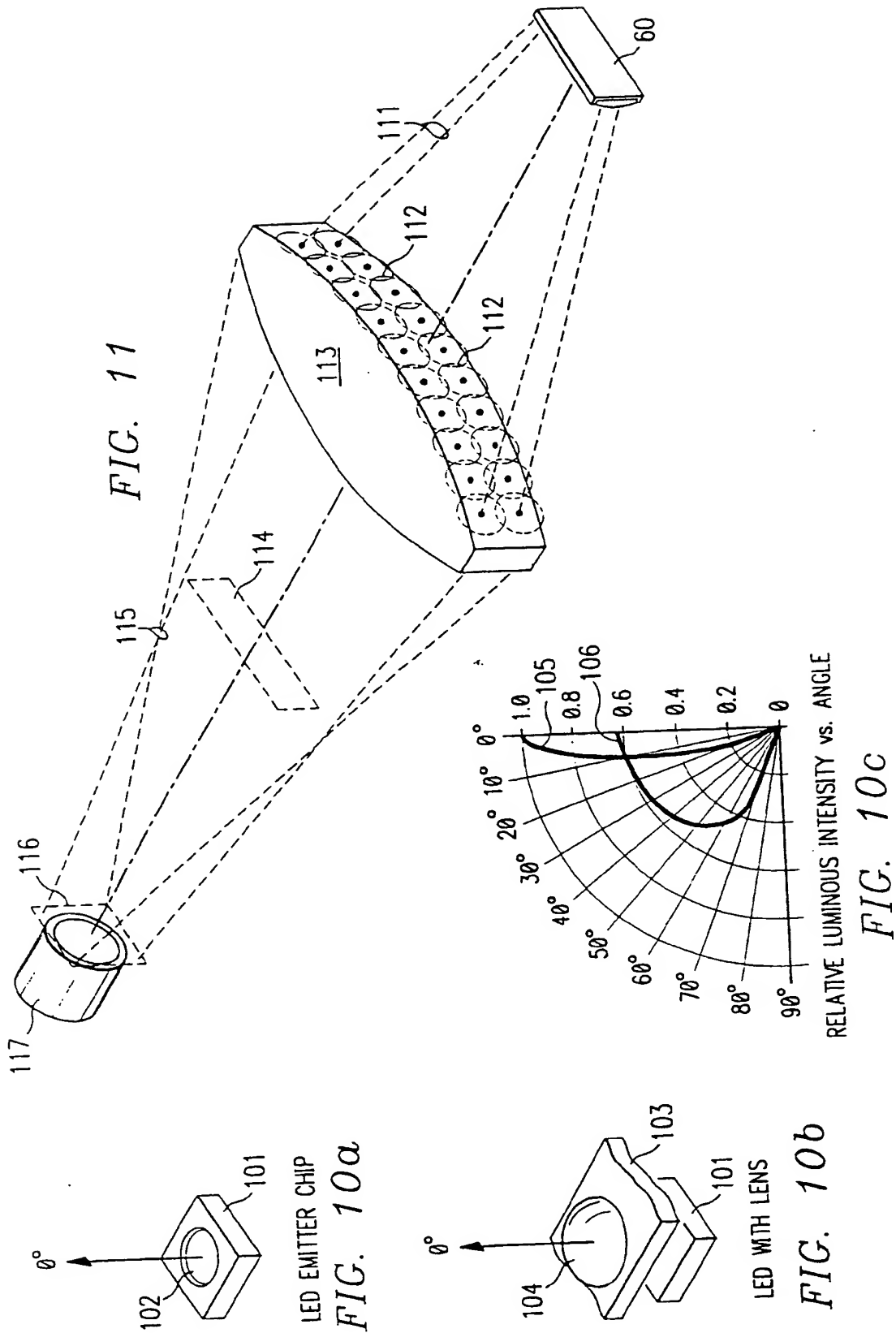


FIG. 3
(PRIOR ART)







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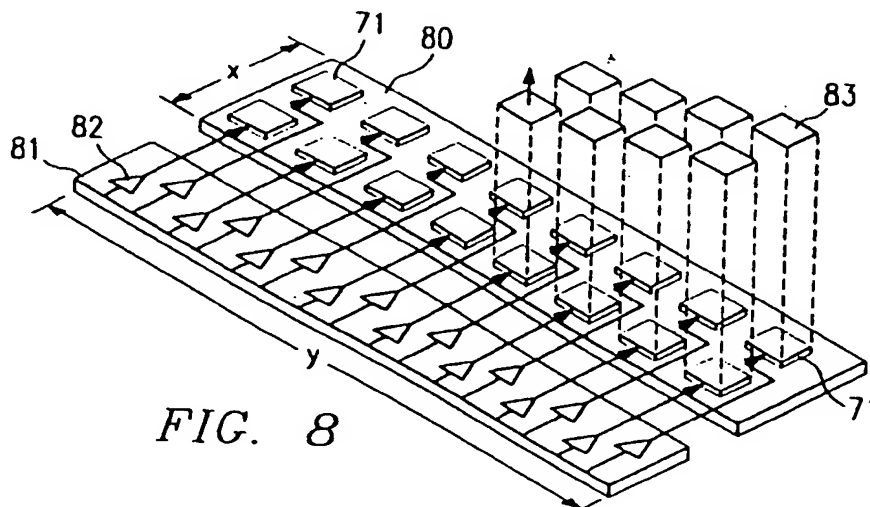
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W-8000 München 60(DE)(54) **System and method for solid state illumination for DMD devices.**

(57) There is disclosed an optic system for illuminating a DMD array in a xerographic printing process consisting of an array of LED emitters (80) constructed to efficiently replace the conventional tungsten source used in prior art. The array can be geometrically configured or electrically operated by

strobing or varying the brightness of individual pixels (71) to compensate for other system optical deficiencies and results in improved printing process. By exposure strobing the LED source correction for fuzzy line edges can be achieved.

**FIG. 8****EP 0 493 800 A3**



European Patent
Office

EUROPEAN SEARCH REPORT

Application Number

EP 91 12 2258

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int. Cl.5)
X	US-A-4 856 863 (SAMPSELL, ET AL) * the whole document *	1, 13, 25, 30	G03G15/04 H04N1/036 G06K15/12 G02B26/08
D, P, A	EP-A-0 433 985 (TEXAS INSTRUMENTS) * figure 7 *	1, 13, 25, 30	
A	EP-A-0 332 953 (TEXAS INSTRUMENTS) * figure 32 *	1, 13, 25, 30	
A	PATENT ABSTRACTS OF JAPAN vol. 11, no. 345 (P-636) 12 November 1987 & JP-A-62 127 707 (CANON) 10 June 1987 * abstract *	1, 13, 25, 30	
A	GB-A-2 123 247 (XEROX) * figure 1 *	1, 13, 25, 30	
A	PATENT ABSTRACTS OF JAPAN vol. 12, no. 464 (M-771)(3311) 6 December 1988 & JP-A-63 189 265 (KONICA) 4 August 1988 * abstract *	1, 13, 25, 30	
			TECHNICAL FIELDS SEARCHED (Int. Cl.5)
			G03G H04N G06K G02B B41J
The present search report has been drawn up for all claims			
Place of search BERLIN		Date of completion of the search 17 JULY 1992	Examiner HOPPE H.
CATEGORY OF CITED DOCUMENTS			
X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document		T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons * : member of the same patent family, corresponding document	

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